

*Fifth International Symposium on
Atomically Controlled Fabrication Technology*

*October 22–24, 2012
Nakanoshima Center, Osaka University, Osaka, Japan*

Best Poster Award

to

Akihiro SUZUKI

*in recognition of the excellent quality poster presentation
entitled:*

*X-ray Ptychography Using Defocused Hard
X-ray Beam*



Kazuto Yamauchi

Kazuto Yamauchi
Chair, Organizing Committee